

 ** **	52433/850 Applicant(s)	10/582,123 Examiner		
	NOMURA et al.	Michael A. Lavilla		

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE

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						TRANSLATION	
EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	Yes	No
/ML/	JP 2001-225008 A	August 21, 2001	JP			Abstract	

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EXAMINER /Michael LaVilla/ DATE CONSIDERED

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INFORMATION DISCLOSURE
STATEMENT BY APPLICANT PTO-1449

Docket No.	Application No.			
52433/850	10/582,123			
Applicant(s)	Examiner			
NOMURA et al.	Michael A. Lavilla			
Filing Date	Confirmation No.	Art Unit		
June 7, 2006	1778	1794		

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OTHER DOCUMENTS

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